

AMENDMENT TO THE CLAIMS:

This listing of claims will replace all prior versions of claims in the application:

LISTING OF CLAIMS:

1. (ORIGINAL) A system for lapping a head, comprising:
 - (a) a wafer including at least one head each having an electrical lapping guide (ELG), a plurality of wafer contacts in electrical communication with the ELG, and a closure formed thereon defining a slot in which the wafer contacts are positioned;
 - (b) a lapping cable coupled to a testing device, the lapping cable including a plurality of lapping cable contacts; and
 - (c) an adapter including a plurality of adapter contacts in electrical communication with the lapping cable contacts;
 - (d) wherein the adapter contacts are removably positionable in electrical communication with the wafer contacts during a lapping process.
2. (ORIGINAL) The system as recited in claim 1, wherein the adapter is constructed from a polyimide material.
3. (CURRENTLY AMENDED) The system as recited in claim 1, wherein the adapter includes a pair of holes formed therein for coupling with a pair of holes formed in the lapping cable via a pair of alignment pins.
4. (ORIGINAL) The system as recited in claim 1, wherein the adapter includes at least one guide for being removably positioned in a slot defined by closures of adjacent heads formed on the wafer.

5. (ORIGINAL) The system as recited in claim 1, wherein the adapter contacts are slidably coupled to the adapter.
6. (ORIGINAL) The system as recited in claim 1, wherein the adapter contacts each include a first portion in electrical communication with one of the lapping cable contacts and a second portion in electrical communication with one of the wafer contacts.
7. (ORIGINAL) The system as recited in claim 6, wherein the first portion of each adapter contact is larger than the second portion of each adapter contact.
8. (ORIGINAL) The system as recited in claim 7, wherein the first portion of each adapter contact has a diameter larger than that of the second portion of each adapter contact.
9. (ORIGINAL) The system as recited in claim 6, wherein the adapter includes a recess for preventing contact with the wafer during the lapping process.
10. (WITHDRAWN) An system for lapping a head, comprising:
 - (a) a wafer including at least one head each having an electrical lapping guide (ELG), a plurality of wafer contacts in electrical communication with the ELG, and a closure formed thereon defining a slot in which the wafer contacts are positioned; and
 - (b) a lapping cable coupled to a testing device, the lapping cable including a plurality of lapping cable contacts extending outwardly therefrom;
 - (c) wherein the lapping cable contacts are removably positionable in electrical communication with the wafer contacts during a lapping process.

11. (WITHDRAWN) The system as recited in claim 10, wherein the lapping cable includes at least one guide for being removably positioned in a slot defined by closures of adjacent heads formed on the wafer.
12. (WITHDRAWN) The system as recited in claim 10, wherein the lapping cable contacts extend in a direction perpendicular with respect to the lapping cable.
13. (WITHDRAWN) The system as recited in claim 10, wherein the lapping cable includes a recess for preventing contact with the wafer during the lapping process.
14. (ORIGINAL) An apparatus for use with a wafer including at least one head each having an electrical lapping guide (ELG), a plurality of wafer contacts in electrical communication with the ELG, and a closure formed thereon defining a slot in which the wafer contacts are positioned, and a lapping cable coupled to a testing device, the lapping cable including a plurality of lapping cable contacts; the apparatus comprising: an adapter including a plurality of adapter contacts in electrical communication with the lapping cable contacts, wherein the adapter contacts are removably positionable in electrical communication with the wafer contacts during a lapping process.
15. (WITHDRAWN) An apparatus for use with a wafer including at least one head each having an electrical lapping guide (ELG), a plurality of wafer contacts in electrical communication with the ELG, and a closure formed thereon defining a slot in which the wafer contacts are positioned, the apparatus comprising:
 - (a) a lapping cable coupled to a testing device, the lapping cable including a plurality of lapping cable contacts extending outwardly therefrom in direction perpendicular with respect to the lapping cable;

- (b) wherein the lapping cable contacts are removably positionable in electrical communication with the wafer contacts during a lapping process.
- 16. (CURRENTLY AMENDED) An adapter including a plurality of adapter contacts [[in]] adapted for electrical communication with a plurality of lapping cable contacts of [[the]] a lapping cable, wherein the adapter contacts are removably positionable in electrical communication with a plurality of wafer contacts of a wafer during a lapping process.
- 17. (CURRENTLY AMENDED) A testing system comprising a lapping cable coupled to a testing device [[and]], the lapping cable including a plurality of lapping cable contacts extending outwardly therefrom in a direction perpendicular with respect to the lapping cable, wherein the lapping cable contacts are removably positionable in electrical communication with a plurality of wafer contacts of a wafer during a lapping process.
- 18. (WITHDRAWN) An adapter including a plurality of adapter contacts in electrical communication with a plurality of lapping cable contacts of the lapping cable, the adapter further including at least one guide for being removably positioned in a slot defined by closures of adjacent heads formed on the wafer, and a recess for preventing contact with the wafer during the lapping process, wherein the adapter contacts are removably positionable in electrical communication with a plurality of wafer contacts of the wafer during a lapping process.
- 19. (WITHDRAWN) A method for testing during a lapping process, comprising:
 - (a) providing an adapter including a plurality of adapter contacts in electrical communication with a plurality of lapping cable contacts of the lapping cable;

- (b) removably positioning the adapter contacts of the adapter in electrical communication with a plurality of wafer contacts of a wafer;
- (c) lapping a surface of the wafer; and
- (d) measuring a head of the wafer during the lapping process.

20. (NEW) A system for lapping a head, comprising:

- (a) a lapping cable coupled to a testing device, the lapping cable including a plurality of lapping cable contacts; and
- (b) an adapter including a plurality of adapter contacts in electrical communication with the lapping cable contacts;
- (c) wherein the adapter contacts are removably positionable in electrical communication with contacts on a wafer during a lapping process.